

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
ICHIRO MIZUSHIMA))
Application No.: 10/608,020) Group Art Unit: 2812
Filed: June 30, 2003)) Examiner: Unknown \
For: METHOD OF PURGING SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE)))))

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicant brings to the attention of the Examiner the documents listed on the attached PTO 1449. This Supplemental Information Disclosure Statement ("IDS") supplements the IDS filed on October 29, 2003, and is being filed before the mailing date of a first Office Action on the merits for the above-referenced application.

Copies of the listed documents are attached.

Applicant respectfully requests that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached form.

Japanese Publication No. 5-331630 is discussed on page 12 of the present

application.

In addition, the article to Mitani et al. is discussed on page 21 of the present

application.

This submission does not represent that a search has been made or that no

better art exists and does not constitute an admission that each or all of the listed

documents are material or constitute "prior art." If the Examiner applies any of the

documents as prior art against any claim in the application and applicant determines

that the cited documents do not constitute "prior art" under United States law, applicant

reserves the right to present to the office the relevant facts and law regarding the

appropriate status of such documents.

Applicant further reserves the right to take appropriate action to establish the

patentability of the disclosed invention over the listed documents, should one or more of

the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please

charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARRETT & DUNNER, L.L.P.

Dated: March 5, 2004

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INFORMATION DISCLOSURE CITATION

		701.7	-		
Atty. Docket No.	4329.3083	YC.9	Appln. No.	10/608,020	
Applicant	Mizushima	MAR 0 5 2004			
Filing Date	June 30, 2003	ELL CAST	Group:	2812	
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Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
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FOREIGN PATENT DOCUMENTS						
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
	5-331630	12/14/93	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				
	Mitani et al., "Reexamination of Fluorine Incorporation into SiO ₂ Significant Improvement of Charge-to-breakdown Distribution Tail," IEEE 37 th Annual International Reliability Physic Symposium (1999), pp. 93-98			

Examiner		Date Considered	
*Examiner:	iner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
Form PTO 14	49 Pater	nt and Trademark Office - U.S. Department of Commerce	